

☐ Pending

☒ Active

☒ L1: (50) (lubricant lubricating lubricated lubrication) near5 (micro adj electro\$3 micro adj elec...

☐ Failed

☒ Saved

☒ S1: (1036) (packag\$5 with (lubricat\$5 wax\$3 grease oil)) with container

☒ S2: (0) (packag\$5 with (lubricat\$5 wax\$3 grease oil)) with container with (micro adj (electronic...

☒ S3: (2) (packag\$5 with (lubricat\$5 wax\$3 grease oil)) with (micro adj (electronic mechanical))

☒ S4: (2) "6300294"

Search L1 Browse Open Clear

DB: US-PG-PUB; USPAT; E: ☒ B: ☒

Default operator: JOR ☒ Highlight all hit terms initially

(lubricant lubricating
lubricated lubrication)
near5 (micro adj electro\$3
micro adj electromechani\$4
microelectro\$8 'mems'
mirror adj device)

☒ BRS form
 ☒ ISAR form
 ☒ Image
 ☒ Text
 ☒ HTML

	U	1	Document I	Issue Dat	Page	Title	Current O	Current X	Retrieval	Inventor	S	C	P	2	3
11	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2004014	2004080	15	Method of preparing free	204/296			Schlenoff, Joseph B	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
12	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2004013	2004071	11	Coating for optical MEM	359/223	359/224		Miller, Seth A. et al	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
13	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2004010	2004052	35	Spatial light modulators	359/291			Huibers, Andrew G.	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
14	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2004010	2004052	38	Spatial light modulators	359/290			Huibers, Andrew G.	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
15	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2004010	2004052	38	Spatial light modulators	349/25			Huibers, Andrew G.	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
16	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2004001	2004012	38	Spatial light modulators	359/291			Huibers, Andrew G.	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
17	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2004000	2004011	20	Direct, low frequency cap	324/683			Pelz, Jonathan P. et	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
18	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2003012	2003071	13	Method and apparatus fo	438/48			Robbins, Roger A.	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
19	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2003010	2003060		MINIATURE RECIPRO	62/6	60/520;		Thiesen, Jack H. et	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
20	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2003006	2003040	7	Methods of applying coat	427/126.3	118/300;		Miller, Seth A.	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
21	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2003005	2003032	27	Methods for depositing, r	438/107			Patel, Satyadev R. e	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
22	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2003001	2003012	11	MEMS device with contr	355/53			Duncan, Walter M.	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
23	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2003000	2003010	14	Lubricating micro-machin	353/119			Miller, Seth	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
24	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2003000	2003010	8	Masking layer in substrat	174/256	174/52.4;		Liu, Jwei Wien et al	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
25	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 2002014	2002101		Miniature reciprocating h	62/6	60/520;		Thiesen, Jack H. et	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>

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21	P	r	US 2003005	2003032	27	Methods for depositing, r	438/107			Patel, Satyadev R. e	r	r	r	r	r
22	P	r	US 2003001	2003012	11	MEMS device with contr	355/53			Duncan, Walter M.	r	r	r	r	r
23	P	r	US 2003000	2003010	14	Lubricating micro-machin	353/119			Miller, Seth	r	r	r	r	r
24	P	r	US 2003000	2003010	8	Masking layer in substrat	174/256	174/52.4;		Liu, Jwei Wien et al	r	r	r	r	r
25	P	r	US 2002014	2002101		Miniature reciprocating h	62/6	60/520;		Thiesen, Jack H. et	r	r	r	r	r
26	P	r	US 2002008	2002070	10	Diluent assisted lubricati	427/58	427/421.1;		Jacobs, Simon Josh	r	r	r	r	r
27	P	r	US 2002006	2002053	18	Micromechanical getter a	257/682	257/E23.0		Robbins, Roger A. e	r	r	r	r	r
28	P	r	US 6909300	2005062	9	Method for fabricating m	324/761	324/754;		Lu, Nai-Cheng et al	r	r	r	r	r
29	P	r	US 6906847	2005061	35	Spatial light modulators	359/291	359/224;		Huibers, Andrew G.	r	r	r	r	r
30	P	r	US 6876071	2005040	6	Masking layer in substrat	257/678	257/701;		Liu, Jwei Wien et al	r	r	r	r	r
31	P	r	US 6856145	2005021	19	Direct, low frequency cap	324/663	324/658		Pelz, Jonathan P. et	r	r	r	r	r
32	P	r	US 6844959	2005011	34	Spatial light modulators	359/297	345/109;		Huibers, Andrew G.	r	r	r	r	r
33	P	r	US 6844623	2005011	11	Temporary coatings for p	257/723	257/682;		Peterson, Kenneth	r	r	r	r	r
34	P	r	US 6841079	2005011	18	Fluorochemical treatment	216/2	216/11;		Dunbar, Timothy D.	r	r	r	r	r
35	P	r	US 6806993	2004101	9	Method for lubricating M	359/291	359/290;		Adams, Lea et al.	r	r	r	r	r